



**ELECTRONIC COPY**

LG783615453  
Report verification at igi.org



April 1, 2026

IGI Report Number **LG783615453**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **14.72 X 10.26 X 6.92 MM**

**GRADING RESULTS**

Carat Weight **10.56 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

April 1, 2026  
IGI Report Number **LG783615453**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **14.72 X 10.26 X 6.92 MM**

**GRADING RESULTS**

Carat Weight **10.56 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

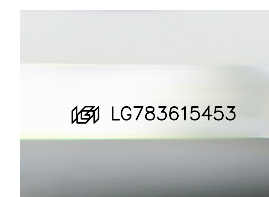
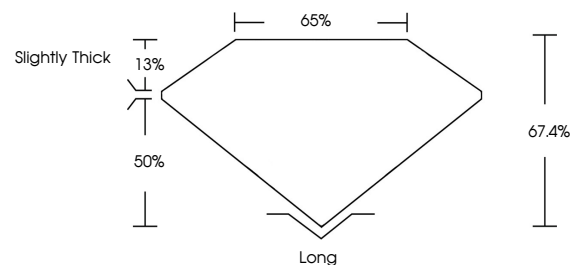
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG783615453**

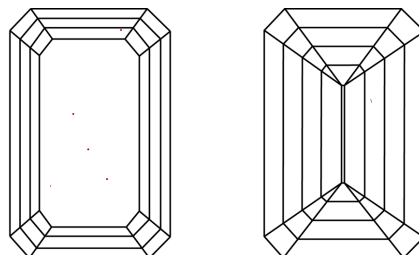
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

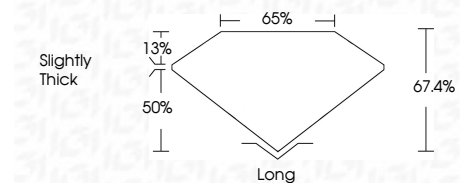
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG783615453**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



**IGI**



April 1, 2026  
IGI Report No **LG783615453**  
**EMERALD CUT**  
**14.72 X 10.26 X 6.92 MM**  
Carat Weight **10.56 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Depth **67.4%**  
Table **65%**  
Girdle **Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG783615453**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa